

Notice of References Cited	Application/Control No. 10/780,671	Applicant(s)/Patent Under Reexamination YADAV, TAPESH	
	Examiner Kallambella Vijayakumar	Art Unit 1751	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,788,738	08-1998	Pirzada et al.	75/331
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*	C	US-5,985,173	11-1999	Gray et al.	252/301.4R
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	Fujishiro et al, "Effect of Microstructural Control on Thermoelectric Properties of Hot-Pressed Aluminum-Doped Zinc Oxide" J. Am Cer. Soc., 2003, 86(12), 2063, Abstract.
	W	Valle et "Transparent and Conductive ZnO:Al thin films prepared by sol-gel dip-coating," J. Eu. Cer. Soc., 2004, 24, 1009-1013.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.